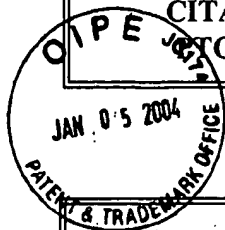


<b>INFORMATION DISCLOSURE CITATION</b> JPO-1449	Atty. Docket No. 990250B	Serial No. 10/685,542
	Applicant(s): MARUYAMA, Shigeyuki et al.	
	Filing Date: October 16, 2003	Group Art Unit: 2829



### U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
_____	AA					
_____	AB					

### FOREIGN PATENT DOCUMENTS

	Document No.	Date	Country	Translation (Yes or No)
<u>RK</u>	AC 06120305A	04/28/94	Japan	Abstract only
<u>RK</u>	AD 10208835A	08/07/98	Japan	Abstract only
<u>RK</u>	AE 1-125568	08/28/89	Japan	No
<u>RK</u>	AF 08227770A	09/03/96	Japan	Abstract only
<u>RK</u>	AG 10079281A	03/24/98	Japan	Abstract only
<u>RK</u>	AH 56-149786	11/19/81	Japan	No
<u>RK</u>	AI 05175274A	07/13/93	Japan	Abstract only
<u>RK</u>	AJ 09055273A	02/25/97	Japan	Abstract only
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Examiner <u><i>[Signature]</i></u> Date Considered <u>10-15-04</u>		



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	Applicant(s): MARUYAMA, Shigeyuki et al.	
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	AA	5,810,609	Faraci et al.	09/22/1998	439	71	
	AB	5,983,492	Fjelstad	11/16/1999	29	843	
	AC	6,499,216	Fjelstad	12/31/2002	29	842	
	AD	6,229,100	Fjelstad	05/08/2001	174	261	
	AE	5,518,964	DiStefano et al.	05/21/1996	437	209	
	AF	5,688,716	DiStefano et al.	11/18/1997	437	182	
	AG	5,706,174	DiStefano et al.	01/06/1998	361	749	
	AH	5,801,441	DiStefano et al.	09/01/1998	257	696	
	AI	5,830,782	Smith et al.	11/03/1998	438	123	
	AJ	5,913,109	DiStefano et al.	06/15/1999	438	117	
	AK	5,959,354	Smith et al.	09/28/1999	257	734	
	AL	5,989,936	Smith et al.	11/23/1999	438	106	
	AM	6,012,224	DiStefano et al.	01/11/2000	29	840	
	AN	6,080,603	DiStefano et al.	06/27/2000	438	117	

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	Document No.	Date	Country	Translation (Yes or No)
	AO 8-31888	02/02/1996	Japan	Abstract
	AP 10-256314	09/25/1998	Japan	Abstract

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	AQ	Notice of Reasons of Rejection issued April 30, 2002 by the Japan Patent Office w/ the partial translation
Examiner		Date Considered 10-15-04

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INFORMATION DISCLOSURE CITATION PTO-1449	Atty. Docket No. 990250B	Serial No.: <del>To Be Assigned</del>
	Applicant(s): MARUYAMA, Shigeyuki et al.	
	Filing Date: October 16, 2003	Group Art Unit: <sup>2829</sup> <del>To Be Assigned</del>

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<i>RK</i>	AA	5,810,609	Faraci et al.	09/22/1998	439	71
<i>RK</i>	AB	5,983,492	Fjelstad	11/16/1999	29	843
<i>RK</i>	AC	6,499,216	Fjelstad	12/31/2002	29	842
<i>RK</i>	AD	6,229,100	Fjelstad	05/08/2001	174	261
<i>RK</i>	AE	5,518,964	DiStefano et al.	05/21/1996	437	209
<i>RK</i>	AF	5,688,716	DiStefano et al.	11/18/1997	437	182
<i>RK</i>	AG	5,706,174	DiStefano et al.	01/06/1998	361	749
<i>RK</i>	AH	5,801,441	DiStefano et al.	09/01/1998	257	696
<i>RK</i>	AI	5,830,782	Smith et al.	11/03/1998	438	123
<i>RK</i>	AJ	5,913,109	DiStefano et al.	06/15/1999	438	117
<i>RK</i>	AK	5,959,354	Smith et al.	09/28/1999	257	734
<i>RK</i>	AL	5,989,936	Smith et al.	11/23/1999	438	106
<i>RK</i>	AM	6,012,224	DiStefano et al.	01/11/2000	29	840
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Document No.	Date	Country	Translation (Yes or No)
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<i>AP</i> 10-256314	09/25/1998	Japan	Abstract

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Examiner <i>R. J. [Signature]</i>	Date Considered 10-15-04

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	Applicant(s): MARUYAMA, Shigeyuki et al.	
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<i>AK</i>	BA	6,104,087	DiStefano et al.	08/15/2000	257	696
<i>AK</i>	BB	6,117,694	Smith et al.	09/12/2000	438	14
<i>RL</i>	BC	2001/0000032	Smith et al.	03/15/2001	438	110
<i>RL</i>	BD	2001/0022396	DiStefano et al.	09/20/2001	257	723
<i>RL</i>	BE	2001/0050425	Beroz et al.	12/13/2001	257	692
<i>RL</i>	BF	2002/0068426	Fjelstad et al.	06/06/2002	438	616
<i>RL</i>	BG	2002/0075016	Fjelstad	06/20/2002	324	724
<i>RL</i>	BH	2002/0148639	Smith et al.	10/17/2002	174	255
<i>RL</i>	BI	6,194,291	DiStefano et al.	02/27/2001	438	455
<i>RL</i>	BJ	6,228,685	Beroz et al.	05/08/2001	438	116
<i>RL</i>	BK	6,265,765	DiStefano et al.	07/24/2001	257	678
<i>RL</i>	BL	6,307,260	Smith et al.	10/23/2001	257	696
<i>RL</i>	BM	6,361,959	Beroz et al.	03/26/2002	435	14
<i>RL</i>	BN	6,370,032	DiStefano et al.	04/09/2002	361	760

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Examiner <i>[Signature]</i>	Date Considered 10-15-04

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RK	CA	6,429,112	Smith et al.	08/06/2002	438	611
RK	CB	6,499,216	Fjelstad	12/31/2002	29	842
RK	CC	5,802,699	Fjelstad et al.	09/08/1998	29	593
RK	CD	5,615,824	Fjelstad et al.	04/01/1997	228	180.1
RK	CE	5,632,631	Fjelstad et al.	05/27/1997	439	82
RK	CF	5,812,378	Fjelstad et al.	09/22/1998	361	769
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RK	CJ	6,205,660	Fjelstad et al.	03/27/2001	29	885
RK	CK	5,915,977	Hembree et al.	06/29/1999	439	74
RK	CL	5,985,682	Higgins, III	11/16/1999	438	10
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RK	CN	5,133,495	Angulas et al.	07/28/1992	228	180.1

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CP			

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INFORMATION DISCLOSURE CITATION PTO-1449	Atty. Docket No. 990250B	Serial No. <del>To Be Assigned</del>
	Applicant(s): MARUYAMA, Shigeyuki et al.	
	Filing Date: October 16, 2003	Group Art Unit: <sup>3829</sup> <del>To Be Assigned</del>

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<i>RK</i>	DA	5,152,695	Grabbe et al.	10/06/1992	439	71
<i>RK</i>	DB	4,121,044	Hadersbeck et al.	10/17/1978	174	68.5
<i>RK</i>	DC	4,107,836	Roberts	08/22/1978	29	625
<i>RK</i>	DD	4,950,173	Minemura et al.	08/21/1990	439	82
<i>RK</i>	DE	4,893,172	Matsumoto et al.	01/09/1990	357	79
<i>RK</i>	DF	5,880,590	Desai et al.	03/09/1999	324	757
<i>RK</i>	DG	5,949,246	Frankeny et al.	09/07/1999	324	765
<i>RK</i>	DH	6,086,386	Fjelstad et al.	07/11/2000	439	70
<i>RK</i>	DI	5,006,792	Malhi et al.	04/09/1991	324	158
<i>RK</i>	DJ	5,625,298	Hirano et al.	04/29/1997	324	754
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